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				Application Number	09/916,064
				Filing Date	7/26/01
				First Named Inventor	Michael Allen Seigler
				Group Art Unit	2812
				Examiner Name	
Sheet	1	of	1	Attorney Docket Number	SEAG 48089

Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
PW		W. PRATT, JR. ET AL, "Perpendicular Giant Magnetoresistances of Ag/Co Multilayers," <i>Physical Review Letters</i> , Vol. 66, No. 23, June 10, 1991, pgs. 3060-3063.	
		M. GIJS ET AL, "Perpendicular Giant Magnetoresistance of Microstructured Fe/Cr Magnetic Multilayers from 4.2 to 300 K," <i>Physical Review Letters</i> , Vol. 70, No. 21, May 24, 1993, pgs. 3343-3346.	
		L. PIRAUX ET AL, "Giant Magnetoresistance in Magnetic Multilayered Nanowires," <i>Appl. Phys. Lett.</i> , Vol. 65, No. 19, November 7, 1994, pgs. 2484-2486.	
		K. BUSSMANN ET AL, "CPP Giant Magnetoresistance of NiFeCo/Cu/CoFe/Cu Multilayers," <i>IEEE Transactions on Magnetics</i> , Vol. 34, No. 4, July 1998, pgs. 924-926.	
		R. HSIAO, "Fabrication of Magnetic Recording Heads and Dry Etching of Head Materials," <i>IBM Journal of Research & Development</i> , Vol. 43, No. 1/2, 1999, pgs. 1-14.	

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Examiner Signature		Date Considered	8/15/03
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